



ELIZADE UNIVERSITY, ILARA-MOKIN, ONDO  
STATE

FACULTY OF ENGINEERING  
DEPARTMENT OF ELECTRICAL AND  
COMPUTER ENGINEERING

FIRST SEMESTER EXAMINATION, 2017/2018 ACADEMIC SESSION

COURSE TITLE: PHYSICAL ELECTRONICS

COURSE CODE: EEE 319

EXAMINATION DATE: 27<sup>TH</sup> MARCH, 2018

COURSE LECTURER: DR. A.M. JUBRIL

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HOD's SIGNATURE

TIME ALLOWED: 3 HOURS

**INSTRUCTIONS:**

1. ANSWER FOUR QUESTIONS ONLY
2. SEVERE PENALTIES APPLY FOR MISCONDUCT, CHEATING, POSSESSION OF UNAUTHORIZED MATERIALS DURING EXAM.
3. YOU ARE NOT ALLOWED TO BORROW ANY WRITING MATERIALS DURING THE EXAMINATION.

**Question One (25 marks)**

- (a) Consider a metal with an FCC structure and an atomic weight of 92.9. When monochromatic x-radiation having a wavelength of 0.1028 nm is focused on the crystal, the angle of diffraction ( $2\theta$ ) for the (311) set of planes in this metal occurs at 71.2 degrees (for the first order reflection  $n=1$ ).
- Calculate the interplanar spacing for this set of planes.
  - Calculate the lattice parameter for this metal.
  - Calculate the density of the metal (units of  $\text{g/cm}^3$ )
- (b) For a bcc lattice of identical atoms with a lattice constant of  $5 \text{ \AA}$ , calculate the maximum packing fraction and the radius of the atoms treated as hard spheres with the nearest neighbors touching.
- (c) Label the planes illustrated in Figures 1a and 1b.

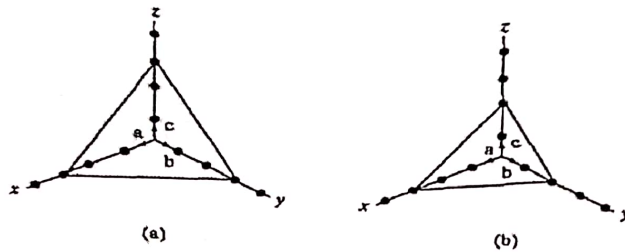


Figure 1

**Question Two (25 marks)**

- (a) A Si sample is doped with  $10^{17} \text{ As atoms/cm}^3$ . What is the equilibrium hole concentration  $P_0$  at 300 K? Where is  $E_F$  relative to  $E_i$ ? Sketch the resulting band diagram.
- (b) Consider a semiconductor bar in Figure 2 with  $w = 0.1 \text{ mm}$ ,  $t = 10 \text{ }\mu\text{m}$ , and  $L = 5 \text{ mm}$ . For  $\mathfrak{B} = 10 \text{ kg}$  in the direction shown ( $1 \text{ kG} = 10^{-5} \text{ Wb/cm}^2$ ) and a current of 1 mA, if  $V_{AB} = -2 \text{ mV}$ ,  $V_{CD} = 100 \text{ mV}$  and  $\mathfrak{B}_z = 10^{-4} \text{ Wb/cm}^2$ . Find the type, concentration, and mobility of the majority carrier.

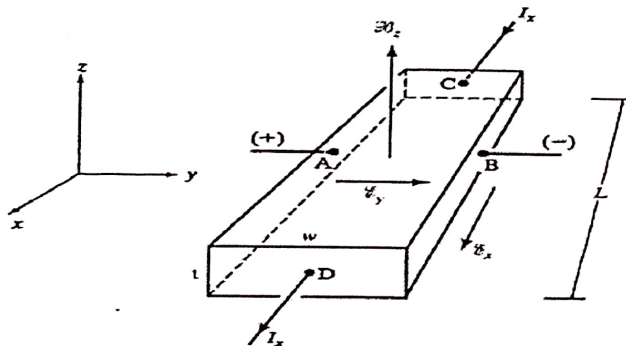


Figure 2

**Question Three (25 marks)**

- (a) An unknown semiconductor has  $E_g = 1.1$  eV and  $N_c = N_v$ . It is doped with  $10^{15}$  cm<sup>-3</sup> donors, where the donor level is 0.2 eV below  $E_c$ . Given that  $E_F$  is 0.25 eV below  $E_c$ , calculate  $n_i$  and the concentration of electrons and holes in the semiconductor at 300 K.

- (b) Show that the minimum conductivity of a semiconductor sample occurs when  $n_o = n_i \sqrt{\frac{\mu_p}{\mu_n}}$ . *Hint, begin with*  $J_x = q(n\mu_n + p\mu_p)E_x = \sigma E_x$  and apply  $n_o p_o = n_i^2$ . What is the expression for the minimum conductivity  $\sigma_{min}$ ? Calculate  $\sigma_{min}$  for Si at 300 K and compare with the intrinsic conductivity.

**Question Four (25 marks)**

- (a) In a very long p-type Si bar with cross-sectional area = 0.5 cm<sup>2</sup> and  $N_a = 10^{17}$  cm<sup>-3</sup>, holes are injected such that the steady state excess hole concentration is  $5 \times 10^{16}$  cm<sup>-3</sup> at  $x = 0$ . What is the steady state separation between  $F_p$  and  $E_c$  at  $x = 1000$  Å? What is the hole current there? How much is the excess stored hole charge? Assume that  $\mu_p = 500$  cm<sup>2</sup>/V-s and  $\tau_p = 10^{-10}$ s.

- (b) In an n-type semiconductor bar, there is an increase in electron concentration from left to right and an electric field pointing to the left. With a suitable sketch, indicate the directions of the electron drift and diffusion current flow and explain why. If the electron concentration is doubled everywhere, what happens to the diffusion current and the drift current? If a constant concentration of electrons is added everywhere, what happens to the drift and diffusion currents? Explain your answers with appropriate equations.

**Question Five (25 marks)**

- (a) Consider the equilibrium band diagram in Figure 3 for a portion of a semiconductor sample with a built-in electric field  $\mathcal{E}$ .

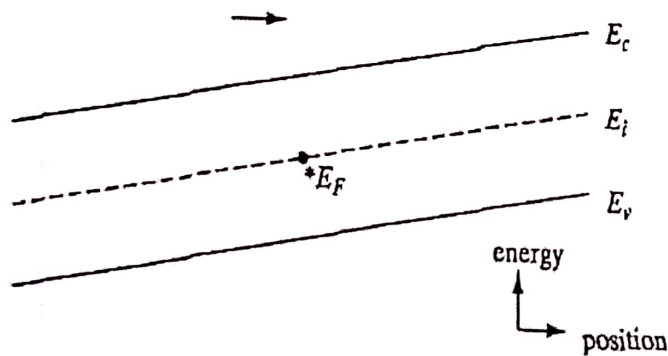


Figure 3

Sketch the Fermi level as a function of position *through* the indicated point,  $E_F$ , across the width of the band diagram above.

On the band diagram, sketch the direction of the electric field. Is the field constant or position dependent?

(b) Derive an expression that relates the carrier diffusivity,  $D$  to Mobility  $\mu$  by the thermal voltage  $KT/q$ .

**Question Six (25 marks)**

(a) An abrupt Si p-n junction ( $A = 10^{-4} \text{cm}^2$ ) has the following properties at 300 K:

P-side	N-side
$N_a = 10^{17} \text{cm}^{-3}$	$N_d = 10^{15} \text{cm}^{-3}$
$\tau_n = 0.1 \mu\text{s}$	$\tau_p = 10 \mu\text{s}$
$\mu_p = 200 \text{cm}^2/\text{V-s}$	$\mu_n = 1300 \text{cm}^2/\text{V-s}$
$\mu_n = 700 \text{cm}^2/\text{V-s}$	$\mu_p = 450 \text{cm}^2/\text{V-s}$

The junction is forward biased by 0.5 V. What is the forward current? What is the current at a reverse bias of -0.5 V?

(b) An abrupt Si p-n junction has  $N_a = 10^{18} \text{cm}^{-3}$  on one side and  $N_d = 5 \times 10^{15} \text{cm}^{-3}$  on the other. (i) Calculate the Fermi level positions at 300 K in the p and n regions. (ii) Draw an equilibrium band diagram for the junction and determine the contact potential  $V_0$  from the diagram. (iii) Compare the results of part (ii) with the calculated value of  $V_0$ .